

S/N 10/ 720,409  
confirmation no. 5057  
Applicant Feng Chen  
Response to Office Action dated 2006-09-25

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Attorney Docket: CS03-039

To: Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: William J. Stoffel 1735 Market St - Ste A455  
Reg no. 39,390 Philadelphia, PA 19103-7502 USA  
Customer no. 30,402  
Work 215-670-2455  
Fax 267-200-0730

## Subject:

S/N 10/ 720,409  
Inventor Feng Chen  
Confirmation no. 5057  
Attorney Docket: CS03-039

File date: 11/24/2003

Title : **CMP Polishing Heads Retaining Ring Groove Design for Microscratch Reduction**

Group Art Unit: 3723  
Examiner: Shakeri

**RESPONSE UNDER 37 CFR 1.116- EXPIDITED PROCEDURE  
- EXAM GROUP 3723-**

RESPONSE TO OFFICE ACTION DATED 2006-09-25

Dear Sir:

Enclosed is a Response to Office Action dated 2006-09-25. Please consider the following remarks:

pls.  
DO NOT  
ENTER  
12/6/6

**CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION****Total 28 Pages in this Fax**

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☐ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450; on the date below.

Signature William J. Stoffel/ DATE November 27, 2006  
William J. Stoffel Reg. No. 39,390 Customer number 30402